

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**In re Application of**

David Abraham et al.

**Serial No.:** 10/680,260

**Group Art Unit:** 2814

**Filed:** October 8, 2003

**Examiner:** Mai, Anh D.

**For:** METHOD AND SYSTEM FOR PATTERNING OF MAGNETIC THIN FILMS  
USING CHEMICAL TRANSFORMATION

Honorable Commissioner of Patents  
Alexandria, VA 22313-1450

**REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. §1.111**

Sir:

In response to the Office Action dated January 3, 2007, please consider the  
following remarks: